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APR 27 2005

Applicant: Akira IMAI, et al.

Serial No: 10/623,849

Filed: July 22, 2003

Title: MANUFACTURING METHOD OF SEMICONDUCTOR  
INTEGRATED CIRCUIT

Group: 1756

Examiner: Kathleen Duda

AMENDMENTCommissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 27, 2005

Sir:

In response to the Office Action dated December 27, 2004, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.